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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO		
09/652,713	08/31/2000	Trung T. Doan	93-0421.04	4284		
7590 08/19/2005			EXAM	EXAMINER		
Charles Brantley			MACARTHUR, SYLVIA			
800 S Federal W Boise, ID 837		•	ART UNIT	PAPER NUMBER		
,			1763	1763		
			DATE MAILED: 08/19/2005			

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Application	No.	Applicant(s)				
Office Action Summary		09/652,713		DOAN, TRUNG T.				
		Examiner		Art Unit				
		Sylvia R. Ma		1763	<u> </u>			
 Period for	The MAILING DATE of this communic	cation appears on the c	over sheet with the c	orrespondence addre	ss			
THE M - Extens after S - If the p - If NO p - Failure Any re	RTENED STATUTORY PERIOD FOR AILING DATE OF THIS COMMUNICATION OF THIS COMMUNICATION OF THIS COMMUNICATION OF THIS FOR THIS COMMUNICATION OF THIS FOR THIS FO	CATION. of 37 CFR 1.136(a). In no event unication. of days, a reply within the statuto utory period will apply and will evill, by statute, cause the applica	, however, may a reply be tin ry minimum of thirty (30) day expire SIX (6) MONTHS from ation to become ABANDONE	nely filed s will be considered timely. the mailing date of this commit (D) (35 U.S.C. § 133).	unication.			
Status			,					
1)⊠ F	Responsive to communication(s) filed	d on 27 June 2005.						
		b)⊠ This action is nor	n-final.		ياسم المعمد			
•	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Dispositio	n of Claims							
4 5)□ (6)⊠ (7)□ (8)□ (Applicatio	he specification is objected to by the	e withdrawn from consion and/or election req	uirement.	by the Evenines				
β F	he drawing(s) filed on <u>13 May 2000</u> in a pplicant may not request that any object Replacement drawing sheet(s) including the oath or declaration is objected to	tion to the drawing(s) be the correction is required	held in abeyance. See if the drawing(s) is obj	e 37 CFR 1.85(a). jected to. See 37 CFR 1	` '			
Priority un	ider 35 U.S.C. § 119							
a) 1 2 3	cknowledgment is made of a claim for All b) Some * c) None of: Certified copies of the priority of the Copies of the priority of the Copies of the certified copies of the application from the Internation the the attached detailed Office actions	locuments have been locuments have been f the priority document al Bureau (PCT Rule	received. received in Applicati ts have been receive 17.2(a)).	ion No ed in this National Sta	ge			
Attachment(s	·		. □	(070 446)				
2)	of References Cited (PTO-892) of Draftsperson's Patent Drawing Review (PT ation Disclosure Statement(s) (PTO-1449 or F No(s)/Mail Date	•			2)			

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DETAILED ACTION

1. The prosecution has been reopended as result of the remand dated 6/27/2005 and the new prior art rejections cited below.

2. Claims 36 and 37 are rejected under 35 U.S.C. 102(b) as being anticipated by Hurtig (USP 5,289,222).

Hurtig discloses drain arrangement for photoresist coating apparatus. In Figure 2, a splash guard (splash controller) 104B is shown around the edge bead removal nozzle 104C and the edge bead of wafer 103.

The splash controller is shown physically unattached from the edge bead and configured to draw chemical toward the splash controller. The splash controller is also configured to physically intercept the chemical. The splashguard (splash controller) inherently generates a gas pressure around the edge bead that is lower than an ambient gas pressure. This lowering of pressure provides the suction.

3. Claims 36 and 37 are rejected under 35 U.S.C. 102(b) as being anticipated by Iwata et al (US 4,611,553).

Iwata et al teaches a dual pipe structure for edge bead removal. The device comprises a dispenser (8) configured to release a chemical toward the edge bead; and a splash controller (4) around the dispenser, physically unattached form the edge and configured to draw the chemical toward the splash controller, wherein the splash controller to generate a pas pressure around the

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edge bead that is lower than the ambient gas pressure, and where the splash controller is

configured to physically intercept the chemical. See col. 2 lines 17-43.

Regarding claim 37: The splash controller is around the edge bead. Herein the definition

of around is taken to be in the vicinity of as cited in Merriam-Webster Online Dictionary (2C),

see Fig. 3.

Response to Arguments

3. Applicant's arguments with respect to claims 36 and 37 have been considered but are

unpersuasive. A new rejection based on Iwata et al has been introduced as a showing of another

interpretation of the claimed invention.

4. <u>Examiner has misinterpreted Hurtig</u>

Applicant cites that claim 36 requires that the splash controller be configured to draw

toward itself a particular chemical. It is also required that the splash controller be configured to

physically intercept the chemical. Applicant argues that the examiner has cited that no portion of

the Hurtig reference indicates that its guard is configured to draw toward itself any chemical. In

response to this argument, examiner has constructed the following comparison table:

Claim 36 of present invention

Hurtig

Dispenser releasing chemical toward edge bead

Edge bead removal nozzle 104C

Splash controller around dispenser

Splash guard 104B

Note: The splash guard of Hurtig is shown physically unattached from the edge bead and configured to draw chemical toward the splash controller. See Figures 1, 2, and 4. The splash guard is also configured to physically intercept the chemical. The splash guard (splash controller) inherently generates a gas pressure around the edge bead that is lower than an ambient gas pressure. This lowering of pressure provides the suction.

Applicant contends that the Examiner cannot meet the burden for rejection relying on Hurtig. Applicant notes that Hurtig's device comprises drain lines 105, 106, 405, and 406 that are configured to draw a chemical toward themselves and away from the splash guard. Applicant argues, however, that the location in relation to Hurtig's splash guard, having both the drain lines and splash guard draw chemicals toward themselves would result in a device whose components compete and interfere with each. Thus, Applicant believes that the device would be unworkable.

In response to this argument, affidavits or declarations attacking the operability of a patent cited as a reference must rebut the presumption of operability by a preponderance of the evidence. In re Sasse, 629 F.2d 675, 207 USPQ 107 (CCPA 1980). See MPEP 716.07.

Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Sylvia R. MacArthur whose telephone number is 571-272-1438. The examiner can normally be reached on M-F during the core hours of 9 a.m. and 3 p.m.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571-272-1435. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Sylvia R MacArthur Patent Examiner Art Unit 1763

August 17, 2005